HEWLETT-PACKARD COMPANY Intellectual Property Administration P. O. Box 272400 Fort Collins, Colorado 80527-2400

PATENT APPLICATION ATTORNEY DOCKET NO. 10004054-1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s): Hodges et al.

Confirmation No.: 8400

Application No.: 10/052,313

Examiner: Lee, H.

Filing Date:

01/18/2002

Group Art Unit: 2823

Title:

Semiconductor Device with Deposited Oxide

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Commissioner for Patents PO Box 1450 Alexandria, VA 22313-1450

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TRANSMITTAL LETTER FOR RESPONSE/AMENDMENT

Sir:

Transmitted herewith is/are the following in the above-identified application:

Response/Amendment

() Petition to extend time to respond

New fee as calculated below

Supplemental Declaration ()

(X)

No additional fee (Address envelope to "Mail Stop Non-Fee Amendment")

() Other: _

(fee \$

(1) FOR	(2) CLAIMS REMAINING AFTER AMENDMENT		(3) NUMBER EXTRA	(4) HIGHEST NUMBER PREVIOUSLY PAID FOR		(5) PRESENT EXTRA		(6) RATE		: (7) ADDITIONAL FEES	
TOTAL CLAIMS		22	MINUS	22			0	х	\$18	\$	0
INDEP. CLAIMS	4		MINUS	4		=	0	× \$86	\$	0	
[] FIR	ST PRES	ENTATION OF A	MULTIPLE	DEPENDENT	CLAIM			+	\$290	\$	0
EXTENSION FEE	1	1ST MONTH \$110.00		МОМПН 0.00	1		MON 480.0		\$	0	
							0	THER	PEES	\$	
				TOTAL A	DDITIONAL FE	E FOR	THIS AI	MEND	MENT	\$	

to Deposit Account 08-2025. At any time during the pendency of this application, please charge any fees required or credit any overpayment to Deposit Account 08-2025 pursuant to 37 CFR 1.25. Additionally please charge any fees to Deposit Account 08-2025 under 37 CFR 1.16, 1.17, 1.19, 1.20 and 1.21. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

(X) I hereby certify that this paper is being transmitted to the Patent and Trademark Office facsimile number (703) 872-9306 Number of pages: 17 on ___01/09/200

Typed Name: Carlin Taylor

Hodges et al.

William J. Breen, Ili

Attorney/Agent for Applicant(s)

Reg. No. 45,313

Date: 01/09/2004

Rev 10/03 (TriAmdFax)

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PAGE 1/17 * RCVD AT 1/9/2004 12:09:42 PM [Eastern Standard Time] * SVR:USPTO-EFXRF-1/1 * DNIS:8729306 * CSID:509 323 8979 * DURATION (mm-ss):04-46

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

OFFICIAL

Application Serial No	10/052_313
Confirmation No	8400
Filing Date	January 18, 2002
Inventor	Hodges et al.
Applicant	Hewlett-Packard Company
Group Art Unit	
Examiner	Lee. Hsien Mino
Attorney's Docket No.	10004054-1
Title: "Semiconductor Device with Deposited Oxide	

RESPONSE TO OFFICE ACTION DATED OCTOBER 31, 2003

To: Commissioner of Patents and Trademarks, P.O. Box 1450

Alexandria, VA 22313-1450

From: William J. Breen, III

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This communication is in response to the Office Action dated October 31, 2003, for which a three-month shortened statutory period for response is set for January 31, 2004. Please amend the above-identified application in accordance the directions set forth below.

Amendments to the Claims are reflected in the listing of claims which begin on page 2 of this paper.

Remarks begin on page 7 of this paper.